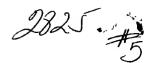


ř







## Docket No 49375 IN THE UNITED STATES PATENT OFFICE $\frac{A}{R}R - \frac{1}{2}$

In re application: M.Kawaguchi

TC 2800 MA \_ KOOM

**Group 2825** 

Serial No 09/470,615

Examiner: n/a

Filed 12/22/99

For mechanism and method for supporting substrate to be coated with film

**Assistant Commissioner of Patents** Washington, D.C. 20231

Sir:

## **CHANGE OF MAILING ADDRESS**

Applicant requests that all further communications from the Patent and Trademark Office in connection with the subject application be sent to the following address:

> Dike, Bronstein, Roberts & Cushman **Intellectual Property Practice Group EDWARDS & ANGELL** P.O. Box 9169 Boston, MA 02209 Tel.: (617) 523-3400

Facsimile: (617) 523-6440

Date: March 30 2001

Name:

George W. Neuner Registration No. 26,984

APR -9 2001

APR 1700